

Introducing the ELS-F125

~ A 125kV EBL System ~



The Award Winning ELS-F125 Features:

- Finest Patterned Lines:
 - 5nm @ 125kV
- Smallest Beam Diameter at High Currents
 - 2.0nm @ 1nA
- Superior Large Field Writing:
 - Uniform 10nm Lines in a 600µm Field
- Reduced Footprint
 - 4m x 3m Minimum Room Size
- New Windows-based Graphical User Interface

www.sts-elionix.com